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Attorney Docket: 960253CIP/HG

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Mitsuru ADACHI et al.
Serial No. : 09/490,983
Filed : January 24, 2000
For : METHOD AND APPARATUS FOR
SHAPING SEMISOLID METALS
Art Unit : 1722
Examiner : LIN

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

S I R :

CERTIFICATE OF MAILING

I hereby certify this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on the date noted below.

Richard S. Barth

Attorney: Richard S. Barth

Dated: December 4, 2001

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this Paper, to Account No. 06-1378.

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This is a response to the Office Action of November 26, 2001 (Paper No. 5) which is a Restriction Requirement under 35 USC 121. The term for responding to the Office Action ends on December 26, 2001.

R E M A R K S

The Examiner is respectfully requested to acknowledge applicants' claim for priority under 35 USC 119 and receipt of the certified copies of the priority documents that were filed in the parent application Serial No. 08/672,378 and parent application Serial No. 08/967,136.

The Examiner is also respectfully requested to return a copy